

Maja Buljan

List of Publications by Year in descending order

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papers

911
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times ranked

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#	ARTICLE	IF	CITATIONS
1	Structural, Optical and Electrical Properties of Al+MoO ₃ and Au+MoO ₃ Thin Films Prepared by Magnetron Codeposition. <i>Materials</i> , 2021, 14, 766.	2.9	2
2	Hollow metal island films as plasmonic sensors produced by galvanic replacement. <i>Surfaces and Interfaces</i> , 2021, , 101483.	3.0	2
3	3D networks of nanopores in alumina: Structural and optical properties. <i>Microporous and Mesoporous Materials</i> , 2021, 325, 111306.	4.4	2
4	Optical absorption in array of Ge/Al-shell nanoparticles in an Alumina matrix. <i>Scientific Reports</i> , 2020, 10, 65.	3.3	7
5	3D Networks of Ge Quantum Wires in Amorphous Alumina Matrix. <i>Nanomaterials</i> , 2020, 10, 1363.	4.1	8
6	Deposition of Thin Alumina Films Containing 3D Ordered Network of Nanopores on Porous Substrates. <i>Materials</i> , 2020, 13, 2883.	2.9	3
7	Ge Quantum Dots Coated with Metal Shells (Al, Ta, and Ti) Embedded in Alumina Thin Films for Solar Energy Conversion. <i>ACS Applied Nano Materials</i> , 2020, 3, 8640-8650.	5.0	10
8	Ge quantum dot lattices in alumina prepared by nitrogen assisted deposition: Structure and photoelectric conversion efficiency. <i>Solar Energy Materials and Solar Cells</i> , 2020, 218, 110722.	6.2	9
9	Real-time tracking of the self-assembled growth of a 3D Ge quantum dot lattice in an alumina matrix. <i>Journal of Applied Crystallography</i> , 2020, 53, 1029-1038.	4.5	3
10	Impact of the Zn source on the RSN-type zeolite formation. <i>Inorganic Chemistry Frontiers</i> , 2019, 6, 2279-2290.	6.0	5
11	Application of GISAXS in the Investigation of Three-Dimensional Lattices of Nanostructures. <i>Crystals</i> , 2019, 9, 479.	2.2	14
12	Studies of bronze corrosion phenomena by EBS and complementary techniques. <i>Nuclear Instruments & Methods in Physics Research B</i> , 2019, 461, 154-158.	1.4	1
13	η -TaON thin films: production by reactive magnetron sputtering and the question of non-stoichiometry. <i>Journal Physics D: Applied Physics</i> , 2019, 52, 305304.	2.8	5
14	Preparation of non-oxidized Ge quantum dot lattices in amorphous Al ₂ O ₃ , Si ₃ N ₄ and SiC matrices. <i>Nanotechnology</i> , 2019, 30, 335601.	2.6	14
15	Influence of Structure on Electronic Charge Transport in 3D Ge Nanowire Networks in an Alumina Matrix. <i>Scientific Reports</i> , 2019, 9, 5432.	3.3	4
16	Infrared spectroscopy of ion tracks in amorphous SiO ₂ and comparison to gamma irradiation induced changes. <i>Journal of Nuclear Materials</i> , 2019, 514, 74-83.	2.7	8
17	Evaluating Automatic Term Extraction Methods on Individual Documents. , 2019, , .		10
18	Recent developments in surface science and engineering, thin films, nanoscience, biomaterials, plasma science, and vacuum technology. <i>Thin Solid Films</i> , 2018, 660, 120-160.	1.8	27

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19	Kinetic Monte Carlo simulation of growth of Ge quantum dot multilayers with amorphous matrix. Journal of Nanoparticle Research, 2017, 19, 1.	1.9	2
20	Temperature behaviour of the average size of nanoparticle lattices co-deposited with an amorphous matrix. Analysis of Ge + Al ₂ O ₃ and Ni + Al ₂ O ₃ thin films. Journal of Physics Condensed Matter, 2017, 29, 435301.	1.8	0
21	Annealing induced semiconductor-metal transition in Ge+ITO film. Applied Physics Letters, 2017, 111, 172104.	3.3	3
22	GISAXS analysis of ion beam modified films and surfaces. Computer Physics Communications, 2017, 212, 69-81.	7.5	4
23	Ta ₂ N ₃ nanocrystals grown in Al ₂ O ₃ thin layers. Beilstein Journal of Nanotechnology, 2017, 8, 2162-2170.	2.8	2
24	Ge/Si core/shell quantum dots in alumina: tuning the optical absorption by the core and shell size. Nanophotonics, 2017, 6, 1055-1062.	6.0	22
25	Modification of semiconductor or metal nanoparticle lattices in amorphous alumina by MeV heavy ions. New Journal of Physics, 2016, 18, 093032.	2.9	6
26	Formation of swift heavy ion tracks on a rutile TiO ₂ (001) surface. Journal of Applied Crystallography, 2016, 49, 1704-1712.	4.5	18
27	Closely packed Ge quantum dots in ITO matrix: influence of Ge crystallization on optical and electrical properties. Materials Research Express, 2016, 3, 065003.	1.6	3
28	Self-assembly of Ge quantum dots on periodically corrugated Si surfaces. Applied Physics Letters, 2015, 107, 203101.	3.3	5
29	Structural characterization of quantum dot lattices by GISAXS: models and software package GisaxStudio. Acta Crystallographica Section A: Foundations and Advances, 2015, 71, s378-s378.	0.1	0
30	Production of three-dimensional quantum dot lattice of Ge/Si core-shell quantum dots and Si/Ge layers in an alumina glass matrix. Nanotechnology, 2015, 26, 065602.	2.6	16
31	Response of GaN to energetic ion irradiation: conditions for ion track formation. Journal Physics D: Applied Physics, 2015, 48, 325304.	2.8	40
32	Evolution of the surface plasmon resonance of Au:TiO ₂ nanocomposite thin films with annealing temperature. Journal of Nanoparticle Research, 2014, 16, 1.	1.9	27
33	Compositionally modulated ripples during composite film growth: Three-dimensional pattern formation at the nanoscale. Physical Review B, 2014, 89, .	3.2	12
34	Effect of bi-layer ratio in ZnO/Al ₂ O ₃ multilayers on microstructure and functional properties of ZnO nanocrystals embedded in Al ₂ O ₃ matrix. Applied Physics A: Materials Science and Processing, 2014, 115, 283-289.	2.3	9
35	Self-assembled growth of Ni nanoparticles in amorphous alumina matrix. Journal of Nanoparticle Research, 2014, 16, 1.	1.9	7
36	Recent advances in vacuum sciences and applications. Journal Physics D: Applied Physics, 2014, 47, 153001.	2.8	33

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37	Fe ₂ O ₃ /TiO ₂ nanoparticles—a complex structural study. <i>Thin Solid Films</i> , 2014, 564, 65-72.	1.8	3
38	Magnetic properties of nickel nanoparticles embedded in amorphous Al ₂ O ₃ matrix. <i>Journal of Physics: Conference Series</i> , 2014, 568, 042022.	0.4	0
39	Ge quantum dot lattices in Al ₂ O ₃ multilayers. <i>Journal of Nanoparticle Research</i> , 2013, 15, 1.	1.9	27
40	Charge storage behavior of nanostructures based on SiGe nanocrystals embedded in Al ₂ O ₃ matrix. <i>European Physical Journal B</i> , 2013, 86, 1.	1.5	5
41	Influence of RF-sputtering power on formation of vertically stacked Si _{1-x} Ge _x nanocrystals between ultra-thin amorphous Al ₂ O ₃ layers: structural and photoluminescence properties. <i>Journal Physics D: Applied Physics</i> , 2013, 46, 385301.	2.8	1
42	Tuning the growth properties of Ge quantum dot lattices in amorphous oxides by matrix type. <i>Journal of Applied Crystallography</i> , 2013, 46, 1490-1500.	4.5	16
43	Growth of a three-dimensional anisotropic lattice of Ge quantum dots in an amorphous alumina matrix. <i>Journal of Applied Crystallography</i> , 2013, 46, 709-715.	4.5	8
44	Materials modification using ions with energies below 1MeV/u. <i>Nuclear Instruments & Methods in Physics Research B</i> , 2013, 317, 143-148.	1.4	3
45	X-ray small-angle scattering from sputtered CeO ₂ /C bilayers. <i>Journal of Applied Physics</i> , 2013, 113, 024301.	2.5	0
46	Co nanocrystals in amorphous multilayers—a structure study. <i>Journal of Applied Crystallography</i> , 2013, 46, 1711-1721.	4.5	5
47	Influence of annealing conditions on the structural and photoluminescence properties of Ge quantum dot lattices in a continuous Ge _x Al _{2-x} O ₃ film. <i>Physica Status Solidi (A) Applications and Materials Science</i> , 2013, 210, 1516-1521.	1.8	2
48	Determination of ion track radii in amorphous matrices via formation of nano-clusters by ion-beam irradiation. <i>Applied Physics Letters</i> , 2012, 101, 103112.	3.3	10
49	Tuning the properties of Ge-quantum dots superlattices in amorphous silica matrix through deposition conditions. <i>Journal of Applied Physics</i> , 2012, 111, 074316.	2.5	4
50	Influence of annealing conditions on the formation of regular lattices of voids and Ge quantum dots in an amorphous alumina matrix. <i>Nanotechnology</i> , 2012, 23, 405605.	2.6	8
51	Structural and electrical studies of ultrathin layers with Si _{0.7} Ge _{0.3} nanocrystals confined in a SiGe/SiO ₂ superlattice. <i>Journal of Applied Physics</i> , 2012, 111, 104323.	2.5	10
52	Conditions for formation of germanium quantum dots in amorphous matrices by MeV ions: Comparison with standard thermal annealing. <i>Physical Review B</i> , 2012, 86, .	3.2	15
53	Grazing-incidence small-angle X-ray scattering: application to the study of quantum dot lattices. <i>Acta Crystallographica Section A: Foundations and Advances</i> , 2012, 68, 124-138.	0.3	61
54	Structural and morphological properties of Fe ₂ O ₃ /TiO ₂ nanocrystals in silica matrix. <i>Thin Solid Films</i> , 2012, 520, 4800-4802.	1.8	1

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55	Preparation of regularly ordered Ge quantum dot lattices in amorphous matrices. <i>Vacuum</i> , 2012, 86, 733-736.	3.5	6
56	X-ray characterization of semiconductor nanostructures. <i>Semiconductor Science and Technology</i> , 2011, 26, 064002.	2.0	2
57	Characterisation of thin LPCVD silicon-rich oxide films. <i>Proceedings of SPIE</i> , 2011, , .	0.8	0
58	Design of quantum dot lattices in amorphous matrices by ion beam irradiation. <i>Physical Review B</i> , 2011, 84, .	3.2	16
59	Low-temperature fabrication of layered self-organized Ge clusters by RF-sputtering. <i>Nanoscale Research Letters</i> , 2011, 6, 341.	5.7	18
60	Surface characterization of thin silicon-rich oxide films. <i>Journal of Molecular Structure</i> , 2011, 993, 214-218.	3.6	6
61	Influence of the deposition parameters on the growth of SiGe nanocrystals embedded in Al ₂ O ₃ matrix. <i>Microelectronic Engineering</i> , 2011, 88, 509-513.	2.4	8
62	Ellipsometric study of thermally induced redistribution and crystallization of Ge in Ge:SiO ₂ mixture layers. <i>Thin Solid Films</i> , 2011, 519, 5419-5423.	1.8	2
63	Electrical Characterization of Ge Nanocrystals in Oxide Matrix. <i>Materials Research Society Symposia Proceedings</i> , 2011, 1305, 1.	0.1	0
64	Multilayers of Ge nanocrystals embedded in Al ₂ O ₃ matrix: Structural and electrical studies. <i>Microelectronic Engineering</i> , 2010, 87, 2508-2512.	2.4	8
65	Structural study of Si _{1-x} Ge _x nanocrystals embedded in SiO ₂ films. <i>Thin Solid Films</i> , 2010, 518, 2569-2572.	1.8	9
66	Structural and charge trapping properties of two bilayer (Ge+SiO ₂)/SiO ₂ films deposited on rippled substrate. <i>Applied Physics Letters</i> , 2010, 97, 163117.	3.3	17
67	Growth of spatially ordered Ge nanoclusters in an amorphous matrix on rippled substrates. <i>Physical Review B</i> , 2010, 82, .	3.2	9
68	Formation of void lattice after annealing of Ge quantum dot lattice in alumina matrix. <i>Applied Physics Letters</i> , 2010, 97, .	3.3	13
69	Self-assembling of Ge quantum dots in an alumina matrix. <i>Physical Review B</i> , 2010, 82, .	3.2	26
70	Generation of an ordered Ge quantum dot array in an amorphous silica matrix by ion beam irradiation: Modeling and structural characterization. <i>Physical Review B</i> , 2010, 81, .	3.2	17
71	Formation of three-dimensional quantum-dot superlattices in amorphous systems: Experiments and Monte Carlo simulations. <i>Physical Review B</i> , 2009, 79, .	3.2	57
72	Formation of long-range ordered quantum dots arrays in amorphous matrix by ion beam irradiation. <i>Applied Physics Letters</i> , 2009, 95, 063104.	3.3	24

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73	Size and spatial homogeneity of SiGe quantum dots in amorphous silica matrix. <i>Journal of Applied Physics</i> , 2009, 106, 084319.	2.5	11
74	The influence of deposition temperature on the correlation of Ge quantum dot positions in amorphous silica matrix. <i>Nanotechnology</i> , 2009, 20, 085612.	2.6	35
75	Grazing incidence X-ray study of Ge-nanoparticle formation in (Ge:SiO ₂)/SiO ₂ multilayers. <i>Thin Solid Films</i> , 2009, 517, 1899-1903.	1.8	10
76	Crystal structure of defect-containing semiconductor nanocrystals – an X-ray diffraction study. <i>Journal of Applied Crystallography</i> , 2009, 42, 660-672.	4.5	6
77	Complementary application of Raman scattering and GISAXS in characterization of embedded semiconductor QDs. <i>Superlattices and Microstructures</i> , 2008, 44, 385-394.	3.1	0
78	Formation of Ge-nanocrystals in SiO ₂ matrix by magnetron sputtering and post-deposition thermal treatment. <i>Superlattices and Microstructures</i> , 2008, 44, 323-330.	3.1	11
79	Raman scattering on quadrupolar vibrational modes of spherical nanoparticles. <i>Journal of Applied Physics</i> , 2008, 104, .	2.5	6
80	Implantation conditions for diamond nanocrystal formation in amorphous silica. <i>Journal of Applied Physics</i> , 2008, 104, 034315.	2.5	2
81	Transmission electron microscopy study of carbon nanophases produced by ion beam implantation. <i>Materials Science and Engineering C</i> , 2006, 26, 1202-1206.	7.3	6
82	Ion beam synthesis and characterization of Ge nanoparticles in SiO ₂ . <i>Nuclear Instruments & Methods in Physics Research B</i> , 2006, 249, 843-846.	1.4	11
83	The evolution of the morphology of Ge nanocrystals formed by ion implantation in SiO ₂ . <i>Nuclear Instruments & Methods in Physics Research B</i> , 2005, 238, 272-275.	1.4	4
84	Influence of stoichiometry deviations on properties of ion-beam synthesized CdSe QDs. <i>Nuclear Instruments & Methods in Physics Research B</i> , 2005, 238, 302-305.	1.4	7
85	Direct ion beam synthesis of II–VI nanocrystals. <i>Nuclear Instruments & Methods in Physics Research B</i> , 2004, 216, 407-413.	1.4	11
86	GISAXS studies of morphology and size distribution of CdS nanocrystals formed in SiO ₂ by ion implantation. <i>Nuclear Instruments & Methods in Physics Research B</i> , 2003, 200, 191-195.	1.4	7
87	Analysis of 2D GISAXS patterns obtained on semiconductor nanocrystals. <i>Vacuum</i> , 2003, 71, 65-70.	3.5	12
88	Ion beam synthesis of buried Zn–VI quantum dots in SiO ₂ – grazing incidence small-angle X-ray scattering studies. <i>Journal of Applied Crystallography</i> , 2003, 36, 439-442.	4.5	6
89	Grazing incidence small-angle X-ray scattering studies of the synthesis and growth of CdS quantum dots from constituent atoms in SiO ₂ matrix. <i>Journal of Applied Crystallography</i> , 2003, 36, 443-446.	4.5	6